

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

August 22, 2003

In re the Application of

Saburo KAMIYA

Group Art Unit: 2877

Application No.: 09/661,433

Examiner:

S. Turner

Filed: September 13, 2000

Docket No.: 107312

For:

EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD I WHICH POSITION

OF REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS MEASURED (AS

AMENDED)

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 25, 2003, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 145487 in the amount of \$410 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00)

X Extension fee for response within second month pursuant to §1.136(a) (\$410.00)

Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

08/25/2003 ZJUHAR1 00000073 09661433

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410.00 DP

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MAC:RJK/mdw

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**DEPOSIT ACCOUNT USE** AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our

Deposit Account No. 15-0461